

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the application of:)	
Yoshito Jin, et al.)	Examiner: Jami M. Valentine
Serial No.: 10/566,522)	
Filed: January 27, 2006)	Art Unit: 2894
For: BISTABLE RESISTANCE VALVE)	
ACQUISITION DEVICE, MANUFACTURING)	
METHOD THEREOF, METAL OXIDE THIN)	
FILM AND MANUFACTURING METHOD)	
<u>THEREOF</u>)	Confirmation No: 5835

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Mail Stop Amendment

Dear Sir:

In response to the outstanding Office Action mailed September 30, 2008 Applicant hereby elects Group I-A, Claims 1-22, drawn to a bistable resistance value acquisition device including a metal oxide layer, classified in class 257, subclass 107.